



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **KADOKURA, Sadao**

Serial No.: 09/998,235

Filed: **December 3, 2001**

Group Art Unit: 1753

Examiner: **Steven H. Versteeg**

P.T.O. Confirmation No.: 5061

For: **FACING-TARGETS-TYPE SPUTTERING APPARATUS AND METHOD**

AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents
Washington, D.C. 20231

March 7, 2003

Sir:

In response to the Office Action dated **December 19, 2002**, please amend the above-identified application as follows:

IN THE DRAWINGS:

Submitted herewith is a Request for Approval of Drawing Corrections, along with proposed drawing corrections to Figure 2B, as marked in red ink.

The applicants respectfully request that the proposed drawing corrections submitted herewith be approved by the Examiner, and that the outstanding objection to the drawings be withdrawn.

IN THE SPECIFICATION:

Amend the specification as follows:

Page 8, paragraph bridging over to page 9, has been amended as indicated below:

However, the above-mentioned facing-targets-type sputtering method has been found to

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W.M.
3/13/03

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TO: 1750 MAIL ROOM

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